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Information Disclosure	Applicant:	10/068,282
Statement By Applicant	Hudson et al.	
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(Use Several Sheets if Necessary)	Herewith 2/4/02	Unassigned

## U.S. Patent Documents

Examiner						Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class_	Date
	A						
	В						0 <b>=</b>
	C						2 = 2
	D						068282 068282
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	F						02/0/
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Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	slation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	J							
	K						<u></u>	<u> </u>
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	M							<u> </u>
	N							

## Other Documents

Examiner					
Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication			
(CAD)	0	Pavlinec, Cross-Linking of Poly(methyl methacrylate) by Aminolysis of Ester Functions with Diamines, Journal of Applied Polymer Science, Vol. 55 (1996) pp. 39-45			
(LW)	P	Kudo, CD Changes Of 193 nm Resists During SEM Measurement, Advances in Resist Technology and Processing XVIII, Proceedings SPIE Vol. 4345 (2001), pp. 179-189			
ILAD	Q	Stern, Electron-Beam Curing of Polymeric Composites as an Enabling Technology for Advanced Manufacturing, <a href="https://www.ebeamservices.com">www.ebeamservices.com</a> , (1999) 8 pages			
Examiner K. Duda		Date Considered 8-7-03			

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.